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AF/1752

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RESPONSE UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE
GROUP 1752
PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q58614

Kenichiro SATO, et al.

Appln. No.: 09/541,597

Group Art Unit: 1752

Confirmation No.: 4840

Examiner: R. ASHTON

Filed: April 3, 2000

For: POSITIVE PHOTORESIST COMPOSITION FOR FAR ULTRAVIOLET
EXPOSURE

RESPONSE UNDER 37 C.F.R. § 1.116

MAIL STOP AF

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated January 12, 2004, please consider the remarks as
submitted herewith on the accompanying pages.